

**Notice of References Cited**

Application/Control No.

09/611,879

Applicant(s)/Patent Under  
Reexamination  
SCHMIDL ET AL.

Examiner

Chuong Ho

Art Unit

2664

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,026,297	02-2000	Haartsen, Jacobus Cornelis	455/426.1
	B	US-5,303,234	04-1994	Kou, Yukari	370/442
	C	US-6,690,657	02-2004	Lau et al.	370/315
	D	US-5,602,836	02-1997	Papadopoulos et al.	370/280
	E	US-5,420,851	05-1995	Seshadri et al.	370/280
	F	US-6,396,457	05-2002	Gatherer et al.	343/853
	G	US-5,684,791	11-1997	Raychaudhuri et al.	370/310.2
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.